

ITW



1110-98029 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/589,587

Applicant: INAGAKI et al.

Filed: 16 August 2006

Art Unit: 1792

Examiner: KUNEMUND, Robert M.

Docket No.: 1110-98029

Customer No.: 24628

Title: METHOD FOR
MANUFACTURING SINGLE
CRYSTAL SEMICONDUCTOR

Confirmation No.: 2705

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AMENDMENT

Sir:

The Office Action of 26 September 2008 has been carefully reviewed and the
following amendments and remarks are made in response thereto.

Amendments to the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.